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PATENT

DEC 05 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application : M. Selim Unlu et al.
Application No. : 10/790,403
Filed : March 1, 2004
Confirmation No. : 1449
For : REFLECTIVE LAYER BURIED IN SILICON
AND METHOD OF FABRICATION
Examiner : Mark V. Prenty
Attorney's Docket : BU-021AX

TC Art Unit: 2822

I hereby certify that this correspondence is being sent via
facsimile to Examiner Mark V. Prenty, TC Art Unit 2822, No. (571)
273 8300, on 12-5-5.

By: 

Charles L. Gagnebin III
Registration No. 25,467
Attorney for Applicant(s)

RESPONSE TO RESTRICTION REQUIREMENT

Via Facsimile
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 6, 2005,
Applicant submits the following remarks.